

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

APPLICANT
Cha-Mei TangFILING DATE
December 13, 2000GROUP
2876

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CEC	5 7 2 9 5 8 5	3/1998	Pellegrino et al.			
CEC	5 8 1 4 2 3 5	9/1998	Pellegrino et al.			
CEC	5 6 0 6 5 8 9	2/1997	Pellegrino et al.			
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CEC	5 9 6 6 4 2 4	10/1999	Liu			
CEC	5 8 4 7 3 9 8	12/1998	Shahar et al.			
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CEC	5 5 7 6 1 4 7	11/1996	Guckel et al.			
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CEC	C.M. Tang, Small Business Information Research Solicitation No. DOE/ER-0686, 21 pages (March 1, 1997). ✓
CEC	C.M. Tang et al., "Anti-Scattering X-Ray Grid", <u>Microsystem Technologies</u> , pages 187-192 (1998). ✓
CEC	Larry E. Antonuk et al., "A Large-Area, 97 μ m Pitch, Indirect-Detection, Active Matrix, Flat-Panel Imager (AMFPI)", <u>Part of the SPIE Conference of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 2-13, (February 1998).</u> ✓
CEC	Radiological Society of North America, 80 th Scientific Assembly and Annual Meeting, November 27-December 2, 1994, page 253. ✓
CEC	Denny L. Lee et al., "Improved Imaging Performance of a 14 x 17-inch Direct Radiography TM System Using Se/TFT Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 14-23 (February 1998).</u> ✓
CEC	Robert Street et al., "Large Area X-Ray Image Sensing Using a PbI ₂ Photoconductor", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 24-32 (February 1998).</u> ✓

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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CEC		5 2 6 3 0 7 5	11/1993	McGann et al.			
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CEC		Tom J.C. Bruijns et al., "Technical and Clinical Results of an Experimental Flat Dynamic (Digital) X-ray Image Detector (FDXD) System with Real-Time Corrections", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 33-44, (February 1998).</u>					
CEC		Christophe Chaussat et al., "New CsI/a-Si 17" x 17" X-Ray Flat Panel Detector Provides Superior Detectivity and Immediate Direct Digital Output for General Radiography Systems", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 45-56 (February 1998).</u>					
CEC		Hans Roehrig et al., "Flat-Panel Detector, CCD Cameras and Electron Beam Tube Based Video Camera for Use in Portal Imaging", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 163-174 (February 1998).</u>					
CEC		Herbert D. Zeman et al., "Portal Imaging with a CsI(Tl) Transparent Scintillator X-Ray Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 175-186 (February 1998).</u>					
CEC		Jean-Pierre Moy, "Image Quality of Scintillator Based X-ray Electronic Imagers", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 187-194 (February 1998).</u>					
CEC		G. Pang et al., "Electronic Portal Imaging Device (EPID) Based on a Novel Camera with Avalanche Multiplication", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 195-203 (February 1998).</u>					
CEC		Michael P. André et al., "An Integrated CMOS-Selenium X-Ray Detector for Digital Mammography", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 204-209 (February 1998).</u>					
CEC		Nicholas Petrick et al., "A Technique to Improve the Effective Fill Factor of Digital Mammographic Imagers", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 210-217 (February 1998).</u>					
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LEC	Richard E. Colbeth et al., "Flat Panel Imaging System for Fluoroscopy Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 376-387 (February 1998).</u>
LEC	Akira Tsukamoto et al., "Development of a Selenium-Based Flat-Panel Detector for Real-Time Radiography and Fluoroscopy", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 388-395 (February 1998).</u> ✓
LEC	N. Jung et al., "Dynamic X-Ray Imaging System Based on an Amorphous Silicon Thin-Film Array", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 396-407 (February 1998).</u> ✓
LEC	Dylan C. Hunt et al., "Detective Quantum Efficiency of Direct, Flat Panel X-ray Imaging Detectors for Fluoroscopy", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 408-417 (February 1998).</u> ✓
LEC	Cornelis H. Slump et al., "Real-Time Diagnostic Imaging with a Novel X-ray Detector with Multiple Screen - CCD Sensors", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 418-429 (February 1998).</u> ✓
LEC	Edmund L. Baker et al., "A Physical Image Quality Evaluation of a CCD-Based X-ray Image Intensifier Digital Fluorography System for Cardiac Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 430-441 (February 1998).</u> ✓
LEC	Richard L. Weisfield et al., "New Amorphous-Silicon Image Sensor for X-Ray Diagnostic Medical Imaging Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 444-452 (February 1998).</u> ✓
LEC	Toshio Kameshima et al., "Novel Large Area MIS-Type X-Ray Image Sensor for Digital Radiography", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 453-462 (February 1998).</u> ✓

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CEL		Gary S. Shaber et al., "Clinical Evaluation of a Full Field Digital Projection Radiography Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 463-469 (February 1998).</u>					
CEL		Donald R. Ouimette et al., "A New Large Area X-Ray Image Sensor", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 470-476 (February 1998).</u>					
CEL		David P. Trauernicht and John Yorkston, "Screen Design for Flat-Panel Imagers in Diagnostic Radiology", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, pages 477-485 (February 1998).</u>					
CEL		John Rowlands and Safa Kasap, "Amorphous Semiconductors Usher in Digital X-Ray Imaging", <u>Physics Today, pages 24-30 (November 1997).</u>					
CEL		N.M. Allinson, "Development of Non-Intensified Charge-Coupled Device Area X-Ray Detectors", <u>Journal of Synchrotron Radiation, pages 54-62 (1994).</u>					
CEL		I.M. Blevis et al., "Digital Radiology Using Amorphous Selenium and Active Matrix Flat Panel Readout: Photoconductive Gain and Gain Fluctuations", <u>Medical Imaging Research, Sunnybrook Science Center, University of Toronto, 8 pages.</u>					
CEL		Justin M. Henry et al., "Noise in Hybrid Photodiode Array - CCD X-Ray Image Detectors for Digital Mammography", <u>SPIE Vol. 2708, pages 106-115 (February 1998).</u>					
CEL		"DpiX' Digital X-Rays for Diagnosis and Treatment", <u>The Clock, pages 3, 5 and 19-21 (December '97/January '98).</u>					
CEL		Russell C. Hardie et al., "Joint MAP Registration and High-Resolution Image Estimation Using a Sequence of Undersampled Images", <u>IEEE Transactions on Image Processing, Vol. 6 No.12, pages 1621-1632 (December 1997).</u>					
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CEC	Joseph C. Gillette et al., "Aliasing Reduction in Staring Infrared Imagers Utilizing Subpixel Techniques", <u>Optical Engineering</u> , Vol. 34, No. 11, pages 3130-3137 (November 1995). ✓
CEC	Russell C. Hardie et al., "High-Resolution Image Reconstruction from a Sequence of Rotated and Translated Frames and its Application to an Infrared Imaging System", <u>Optical Engineering</u> , Vol. 37, No. 1, pages 247-260, (January 1998). ✓
CEC	Kai M. Hock, "Effect of Oversampling in Pixel Arrays", <u>Optical Engineering</u> , Vol. 34, No. 5, pages 1281-1288 (May 1995). ✓
CEC	Kenneth J. Barnard et al. "Effects of Image Noise on Submicroscan Interpolation", <u>Optical Engineering</u> , Vol. 34, No. 11, pages 3165-3173 (November 1995). ✓
CEC	Kenneth J. Barnard et al., "Nonmechanical Microscanning Using Optical Space-Fed Phased Arrays", <u>Optical Engineering</u> , Vol. 33, No. 9, pages 3063-3071 (September 1994). ✓
CEC	Gerald C. Holst, <u>Sampling, Aliasing, and Data Fidelity</u> , pages 98-130 (published prior to Feb. 18, 1999). ✓
CEC	Larry E. Antonuk et al., "Demonstration of Megavoltage and Diagnostic X-Ray Imaging with Hydrogenated Amorphous Silicon Arrays", <u>Am. Assoc. Phys. Med.</u> , Vol. 19, No. 6, pages 1455-1466 (Nov/Dec 1992). ✓

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OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)									
CEL		E.W. Becker et al., "Fabrication of Microstructures with high aspect ratios and great structural heights by synchrotron Radiation Lithography, Galvanoforming, and Plastic Molding (LIGA Process)," <u>Microelectronics Engineering</u> , Vol. 4 pages 35-56 (1986).							
CEL		Dr. P. Bley, "The Liga Process for Fabrication of Three-Dimensional Microscale Structures," <u>Interdisciplinary Sci. Rev.</u> , Vol. 18, pages 267-272 (1993).							
CEL		"DARPA Awards Contract for X-Ray Lithography System", <u>Micromachine Devices</u> , Vol. 2, No. 3, page 2 (1997).							
CEL		R.L. Egan, "Intramammary Calcifications Without an Associated Mass", <u>Radiology</u> , Vol. 137, pages 1-7 (1980).							
CEL		H. Guckel, program and notes describing his "Invited talk at the American Vacuum Society Symposium", Philadelphia, PA, Oct. 1996.							
CEL		"IBM Team Develops Ultrathick Negative Resist for MEMs Users", <u>Micromachine Devices</u> , Vol. 2, No. 3, page 1 (1997).							
CEL		"X-Ray Lithography Scanners for LIGA", <u>Micromachine Devices</u> , Vol. 1, No. 2, page 8 (1996).							
CEL		E.P. Muntz et al., "On the Significance of Very Small Angle Scattered Radiation to Radiographic Imaging at Low Energies", <u>Med. Phys.</u> Vol. 10, pages 819-823 (1983).							
CEL		M.J. Yaffe et al., "X-Ray Detectors for Digital Radiography", <u>Phys. Med. Biol.</u> , Vol. 42, pages 1-39 (1997).							

EXAMINER <i>Chun</i>	DATE CONSIDERED 12/01
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CEL		D.P. Siddons et al., "Precision Machining using Hard X-Rays", <u>Synchrotron Radiation News</u> , Vol. 7, No. 2, pages 16-18 (1994).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/liga.html", entitled "UW-MEMS-Research-Deep X-ray Lithography" (web site information available to public prior to June 19, 1987 filing date of present application).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/pc.html" entitled "UW-MEMS-Research-Precision Engineering" (web site information available to public prior to June 19, 1987 filing date of present application).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/~guckel/homepage.html" (web site information available to public prior to June 19, 1987 filing date of present application).					
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CEL	H. Guckel, "NATO Advanced Research Workshop on the Ultimate Limits of Fabrication and Measurement", <u>Proceedings of the Royal Society (Invited Talk/Paper)</u> , pages 1-15 (April 1994).
CEL	H. Guckel et al., "Micromechanics via x-ray assisted processing", <u>Journal of Vacuum Science Technology</u> , pages 2559-2564 (July/August 1994).
CEL	W. Ehrfeld, "Coming to Terms with the Past and the Future", <u>LIGA News</u> , pages 1-3 (January 1995).
CEL	H. Guckel et al., "Micro Electromagnetic Actuators Based on Deep X-Ray Lithography", <u>MIMR '95, Sendai, Japan</u> , (September 27-29, 1995).
CEL	H. Guckel et al., "Micromechanics for actuators via deep x-ray lithography", <u>Proceedings of SPIE, Orlando, Florida</u> , pages 39-47 (April 1994).
CEL	Z. Jing et al., "Imaging characteristics of plastic scintillating fiber screens for mammography", <u>SPIE</u> , Vol. 2708, pages 633-644 (February 1996).
CEL	N. Nakamori et al., "Computer simulation on scatter removing characteristics by grid", <u>SPIE</u> Vol. 2708, pages 617-625 (February 1996).
CEL	P. A. Tompkins et al., "Use of capillary optics as a beam intensifier for a Compton x-ray source", <u>Medical Physics</u> , Vol. 21, No. 11, pages 1777-1784 (November 1994).

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CEL		L.E. Antonuk et al., "Large Area, Flat-Panel, Amorphous Silicon Imagers", <u>SPIE</u> Vol. 2432, pages 216-227 (July 1995).					
CEL		H.E. Johns, OC, Ph.D., F.R.S.C., LL.D., D.Sc., F.C.C.P.M., <u>The Physics of Radiology</u> , Fourth Edition (Charles C. Thomas: Springfield, Illinois, 1983), page 734.					
CEL		Collimated Holes, Inc. Products Manual, pages entitled "Rectangular and Square Fibers/Fiber Arrays" (April 1995) and "Scintillating Fiberoptic Faceplate Price List Type LKH-6" (December 1995).					
CEL		H. Guckel et al., "LIGA and LIGA-Like Processing with High Energy Photons", <u>Microsystems Technologies</u> , Vol. 2, No. 3, pages 153-156 (August 1996).					
CEL		H. Guckel et al., "Deep X-Ray Lithography for Micromechanics and Precision Engineering", <u>Synchrotron Radiation Instrumentation (Invited)</u> , Advanced Photon Source Argonne, pages 1-8 (October 1995).					
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